

ASME Internal Combustion Engine Division

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High-T NO_x Sensing Elements using Conductive Oxides and Pt

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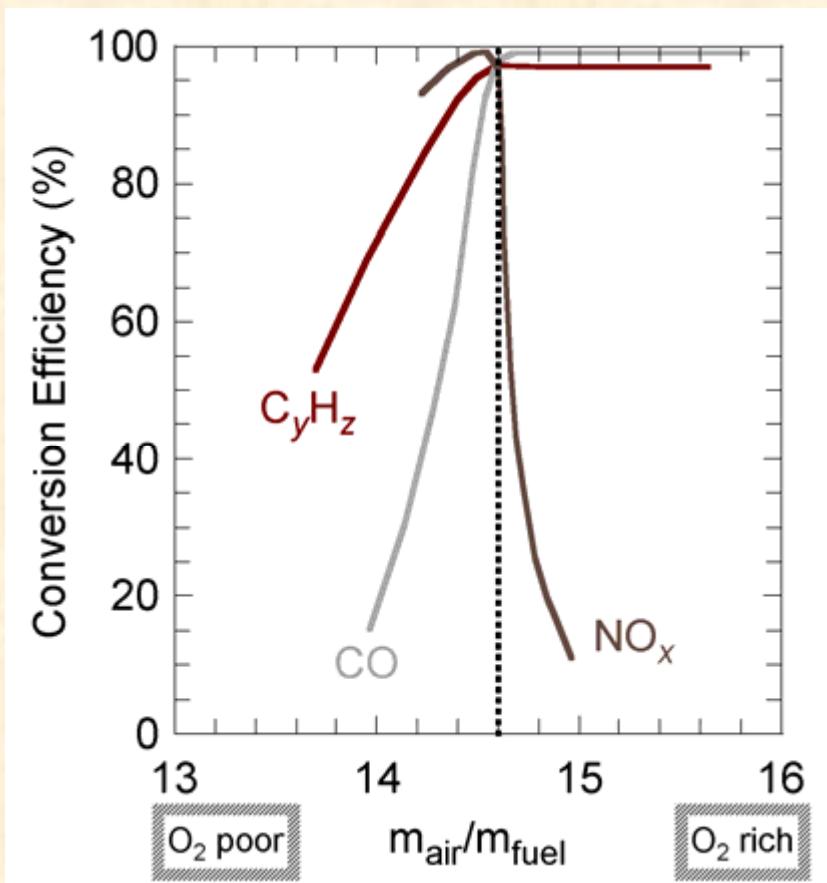
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Background I – need for NO_x sensors

Three-way catalyst (TWC) efficiency[†]



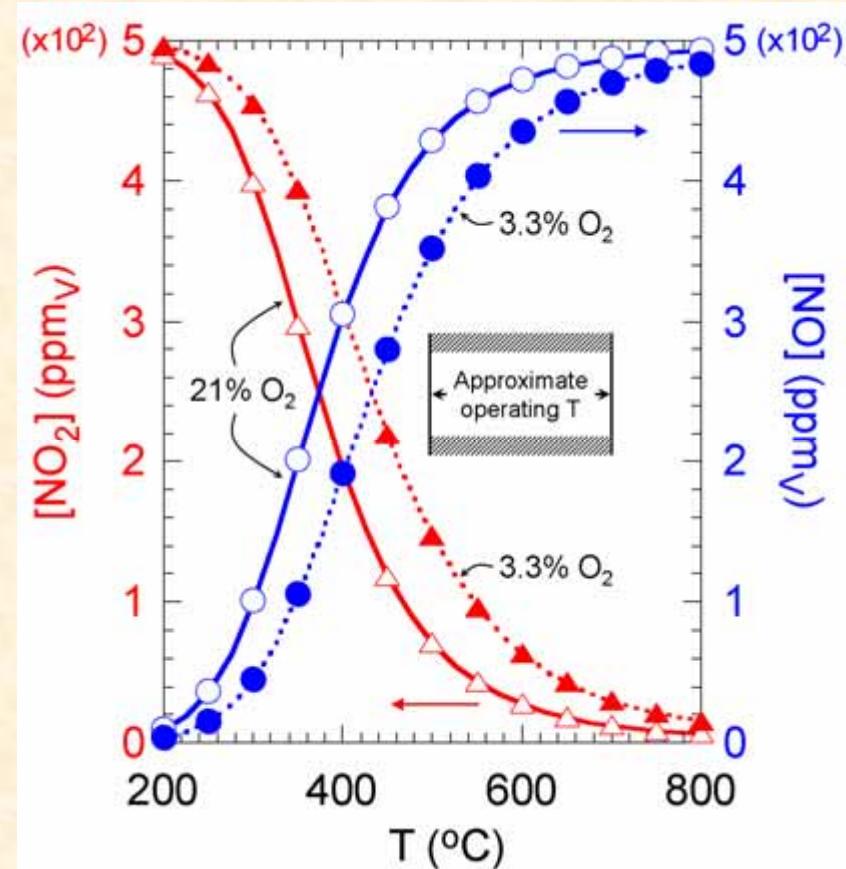
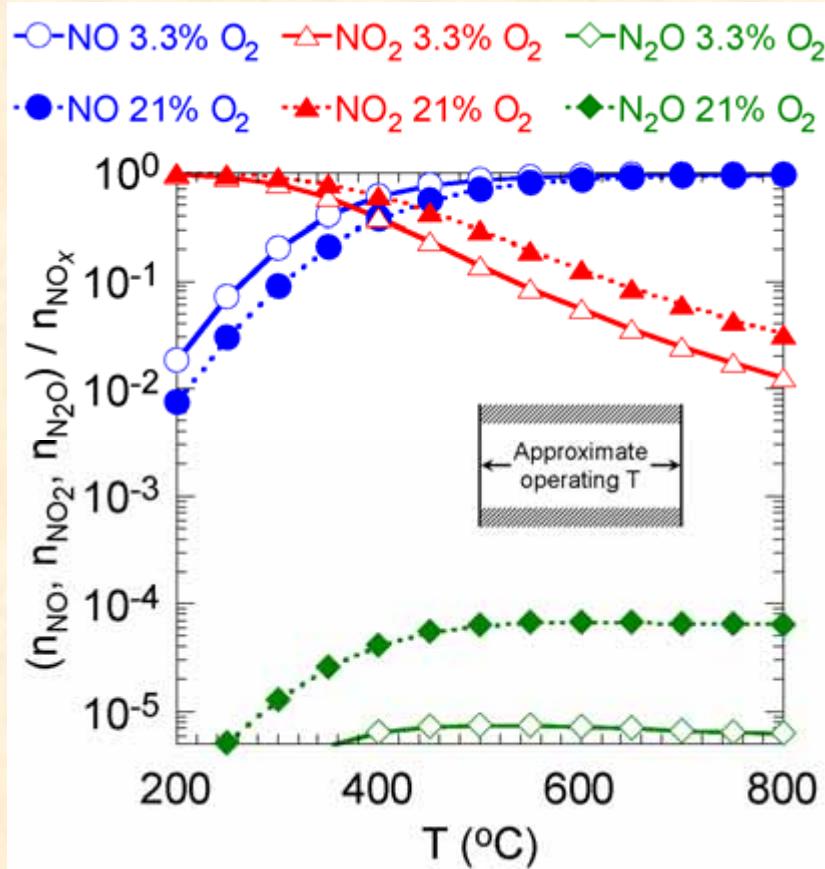
- ⇒ Currently, TWC unable to remove NO_x from O_2 -rich (e.g., diesel, lean-burn) exhausts.
- ⇒ These exhausts will require NO_x remediation with NO_x traps (LNT) or reagent injection (SCR).
- ⇒ Both technologies will require compact and robust NO_x sensors.
- ⇒ Sensor controls trap regeneration for LNT, reagent injection for SCR.
- ⇒ Sensor operating conditions:
 $T \sim 600^\circ\text{C}$, $\sim 10\text{--}1000 \text{ ppm}_V \text{ NO}_x$, varying $[\text{O}_2]$.[‡]

[†]Woestman and Logothetis, *The Industrial Physicist*, 1, (1995).

[‡]Menil, Coillard, and Lucat, *Sensors and Actuators B*, 67, (2000).

Background II: NO_x species

Equilibrium NO_x abundances[†]



⇒ NO is dominant equilibrium NO_x species above 500 °C.

Experimental approach and methodology

⇒ Experimental approach

- ◆ High-T NO_x sensing elements based on YSZ.
 - ⇒ Co-planar sensing elements (conductive oxide / Pt).
- ◆ Vary conductive oxide and element geometry.
- ◆ Study effects of DC constant current "bias".[†]

⇒ Methodology

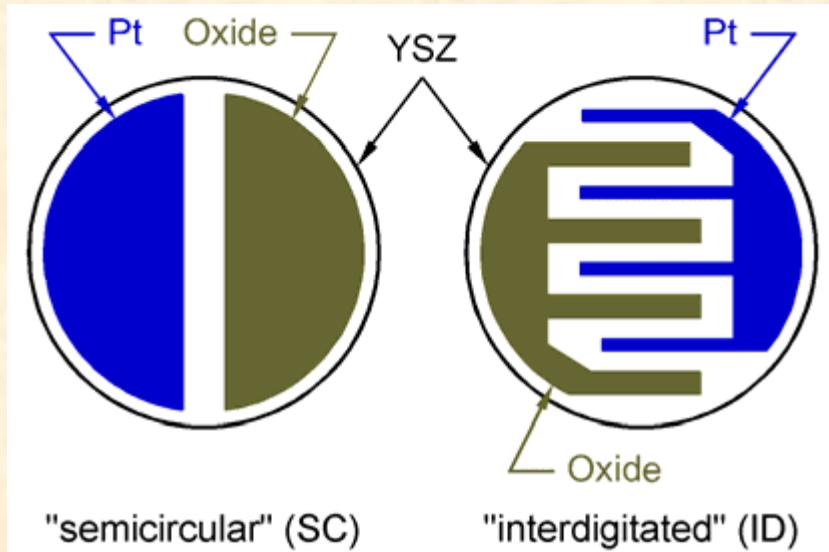
- ◆ Electrodes applied by screen printing and thermal treatment.
- ◆ Tube furnace used to simulate elevated temperature service.
- ◆ Test parameter boundaries:
 - ⇒ $500 \text{ }^\circ\text{C} \leq T \leq 700 \text{ }^\circ\text{C}$.
 - ⇒ $20 \text{ ppm}_V \leq [\text{NO}_x] \leq 1500 \text{ ppm}_V$, $[\text{O}_2] = 7\text{--}20 \text{ vol\%}$, bal. = N_2 .

⇒ Performance metrics

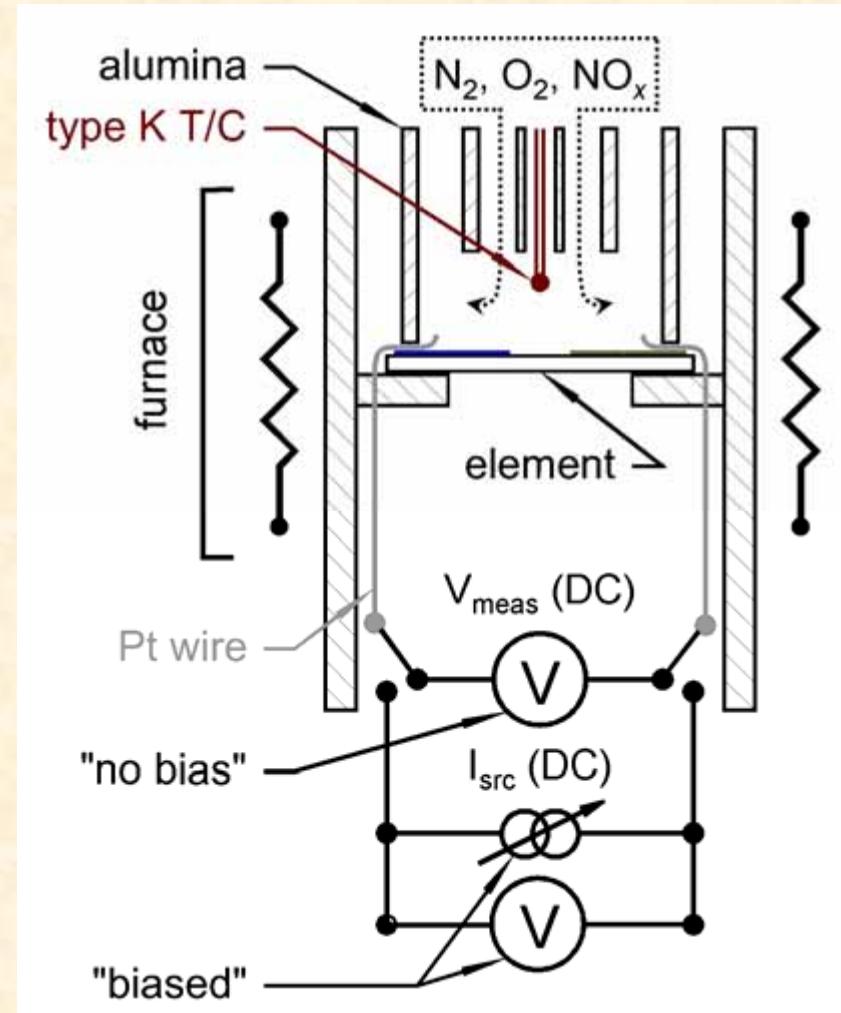
- ◆ NO_2 and NO response magnitude, effect of varying $[\text{O}_2]$.
- ◆ Response/recovery time.

[†]Miura *et al.*, *Solid State Ionics*, **65**, pp. 283-90 (1999);
Ho *et al.*, *Journ. Cer. Soc. Jpn.*, **104**, pp. 995-9 (1996);
Grilli *et al.*, *Journ. Electrochem. Soc.*, **148**, pp. H98-102 (2001);

Sensing element geometries, test fixture schematic

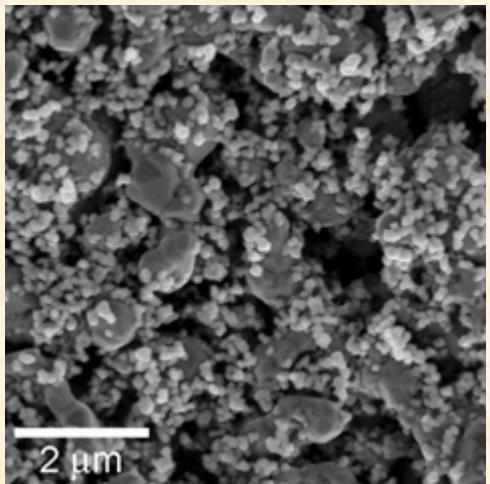


- ⇒ YSZ (Tosoh TZ8YS) substrate.
- ◆ dia. ~16 mm, thickness ~1 mm.
- ⇒ Screen printed electrodes.
- ◆ T_{fire} ($^{\circ}\text{C}$) = 1100 (Pt), 900 (oxide).
 - ◆ Oxides: $\text{La}_{0.85}\text{Sr}_{0.15}\text{CrO}_3$ (LSC),
 $\text{La}_{0.85}\text{Ba}_{0.15}\text{CrO}_3$ (LBC),
 $\text{La}_{0.80}\text{Sr}_{0.20}\text{FeO}_3$ (LSF).

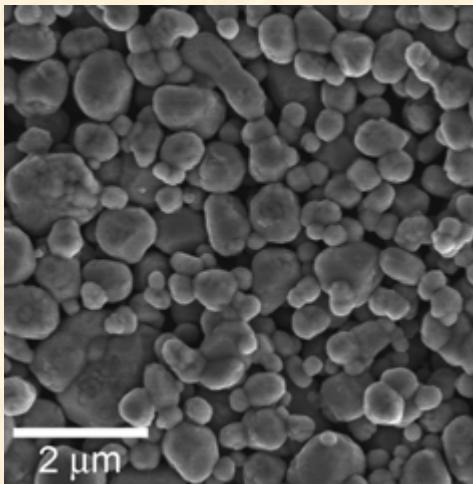


Electrode microstructures and thickness

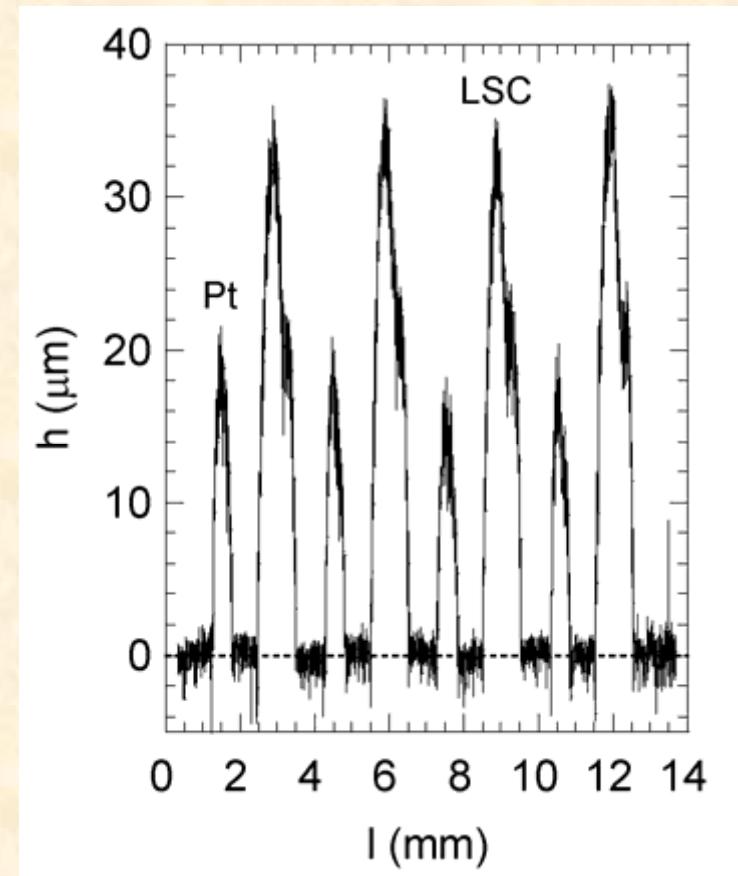
Pt



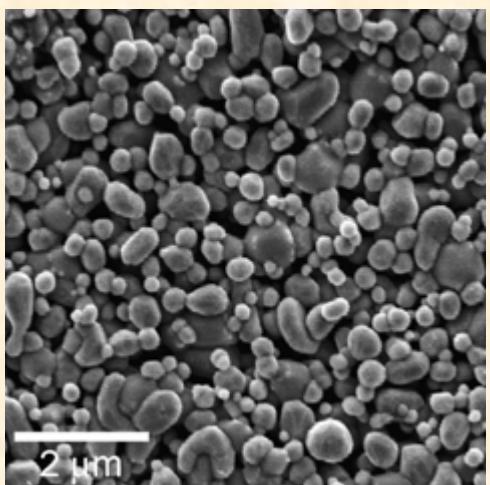
LSC



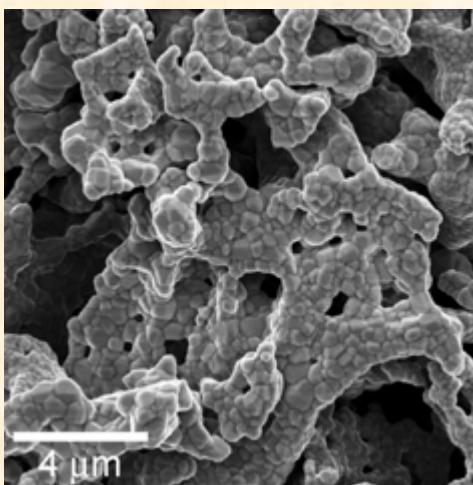
LSC/Pt interdigitated



LBC

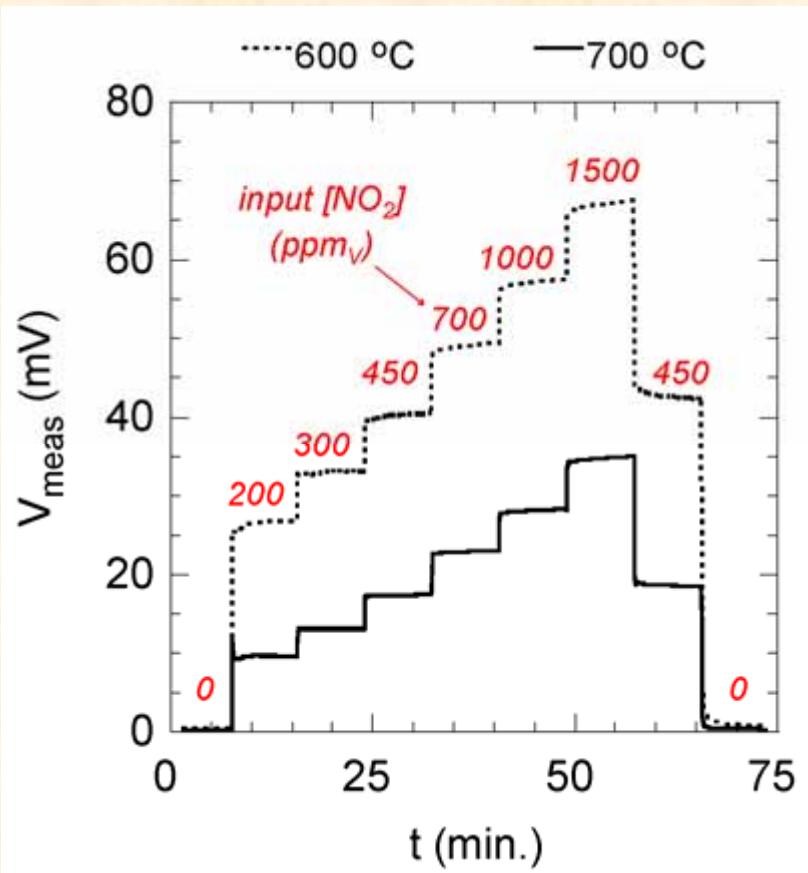


LSF

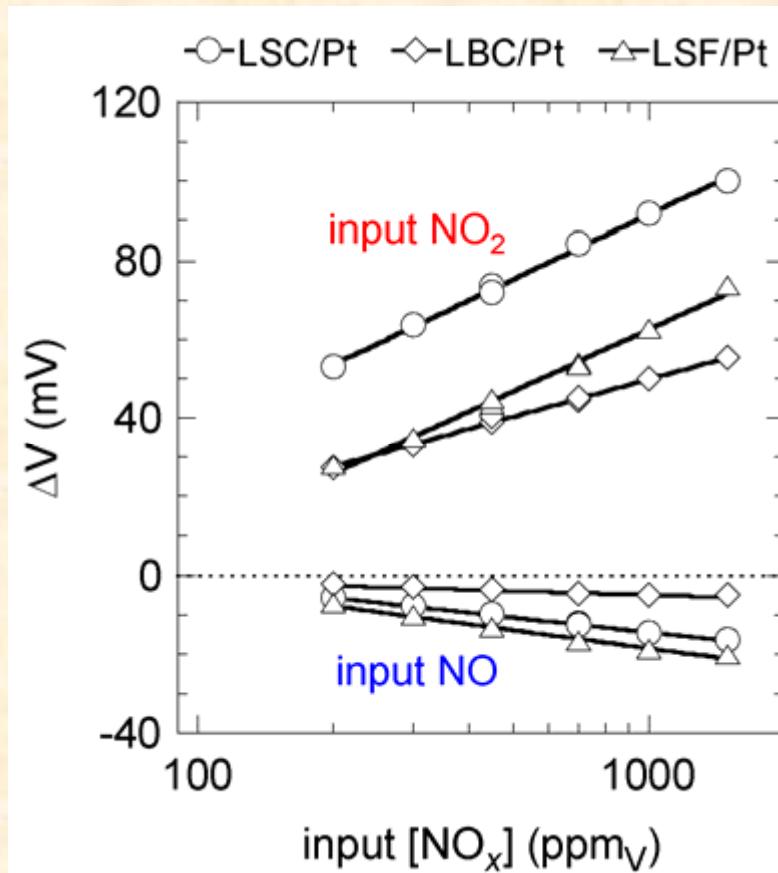


No bias: Strong NO₂ response

$$V_{\text{meas}} = f(t) \text{ (LSF/Pt, 13 vol\% O}_2)$$



$$V_{\text{meas}} = f([\text{NO}_x]) \text{ (600 }^{\circ}\text{C, 7 vol\% O}_2)$$



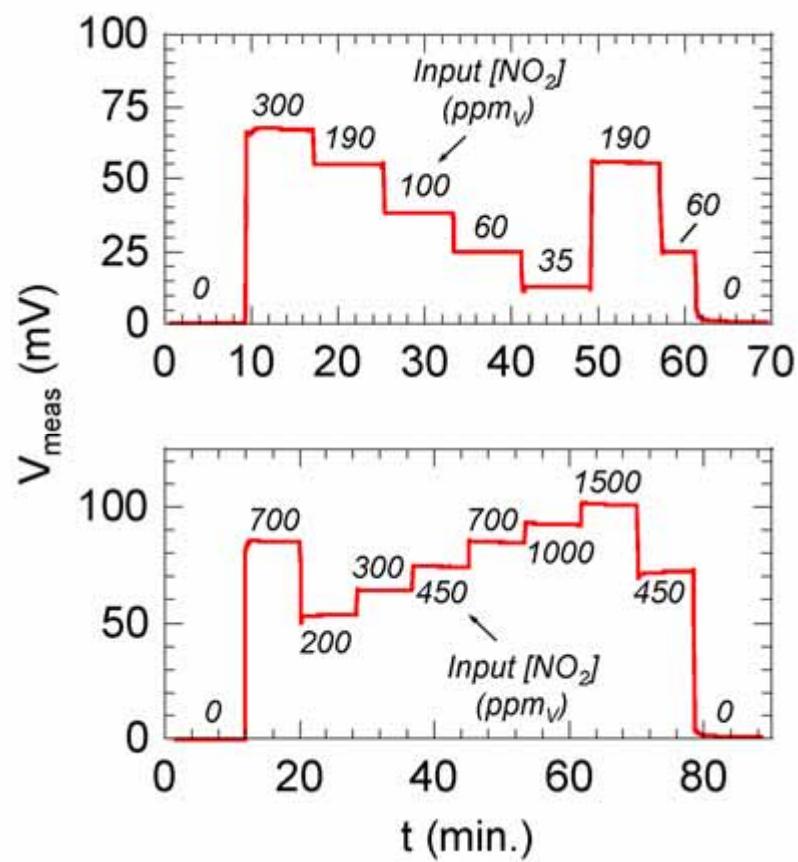
- ⇒ Semicircular (SC) geometries.
- ⇒ Mechanism for *in situ* $\text{NO}_x \rightarrow \text{NO}_2^{\dagger}$ required, focus on NO_2 response.

[†]Szabo and Dutta, *Sens. Actuators B; Chem.*, **88**, pp. 168-77 (2002);

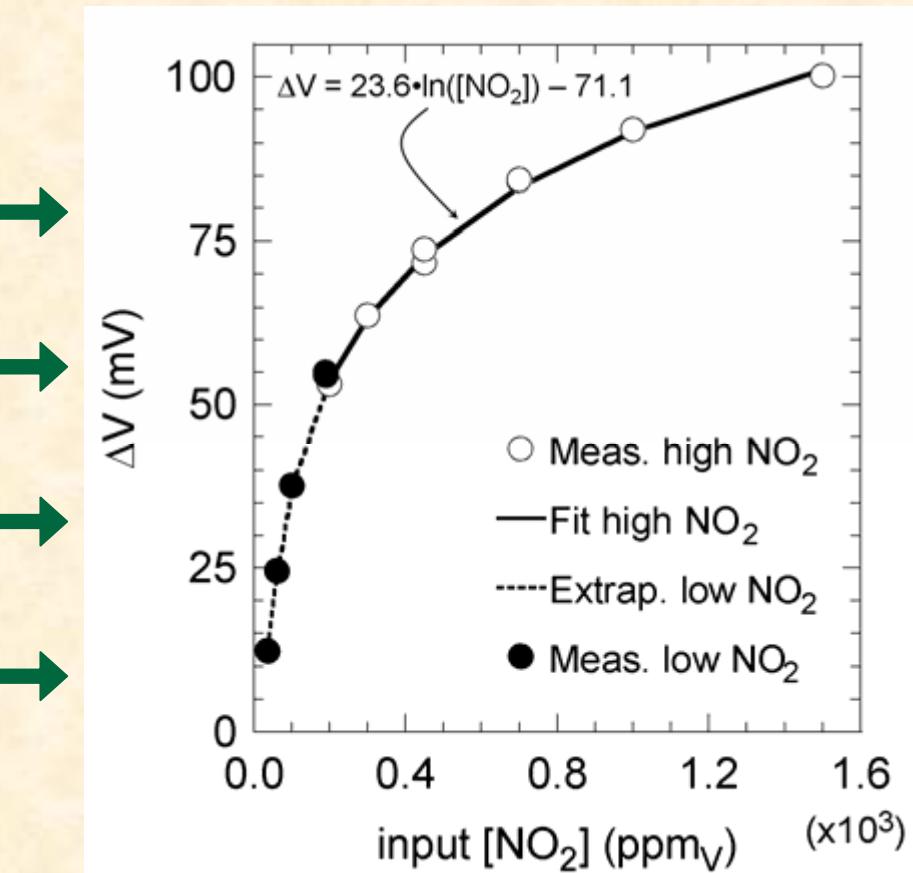
Kunimoto *et al.*, *SAE Tech. Pap. Ser.* 1999-01-1280 (1999)

No bias: Logarithmic signal over a wide $[NO_2]$

$$V_{\text{meas}} = f(t)$$



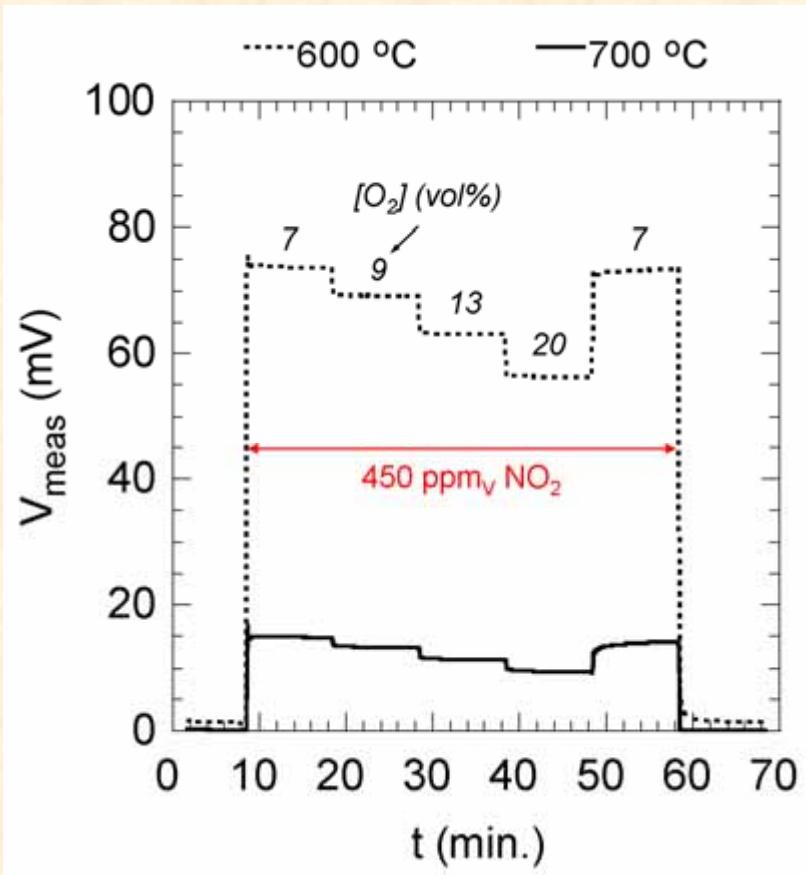
$$\Delta V = f([NO_2])$$



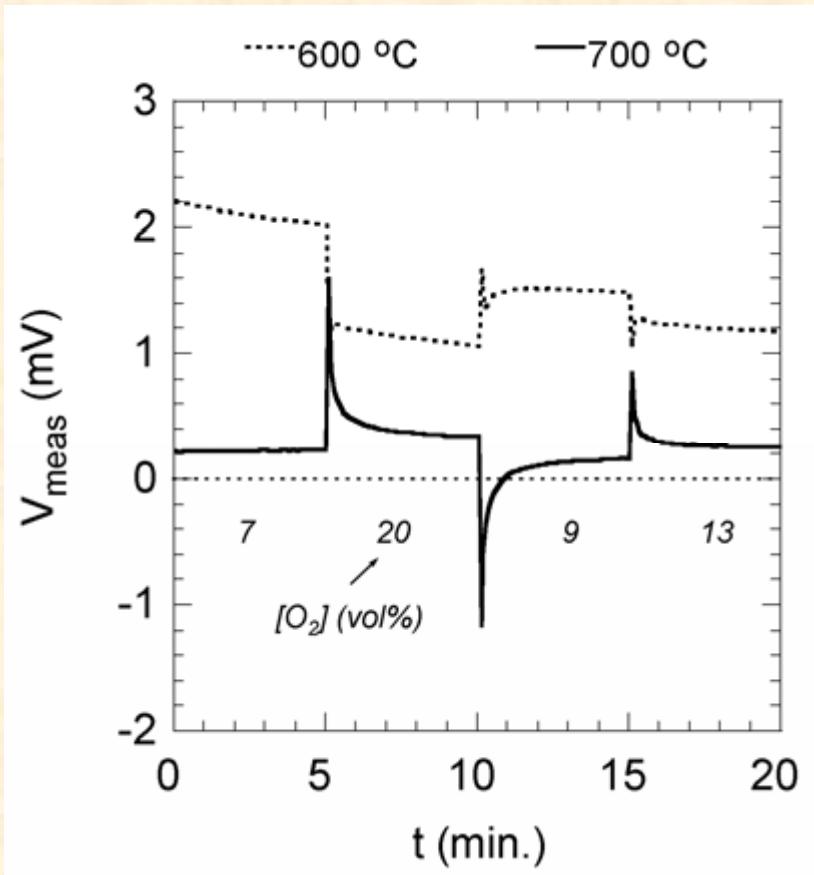
- ⇒ Data collected at 600 °C, 7 vol% O₂.
- ⇒ LSC/Pt sensing element, semicircular (SC) geometry.

[O₂] affects response to NO₂

Varying [O₂] with 450 ppm_v NO₂



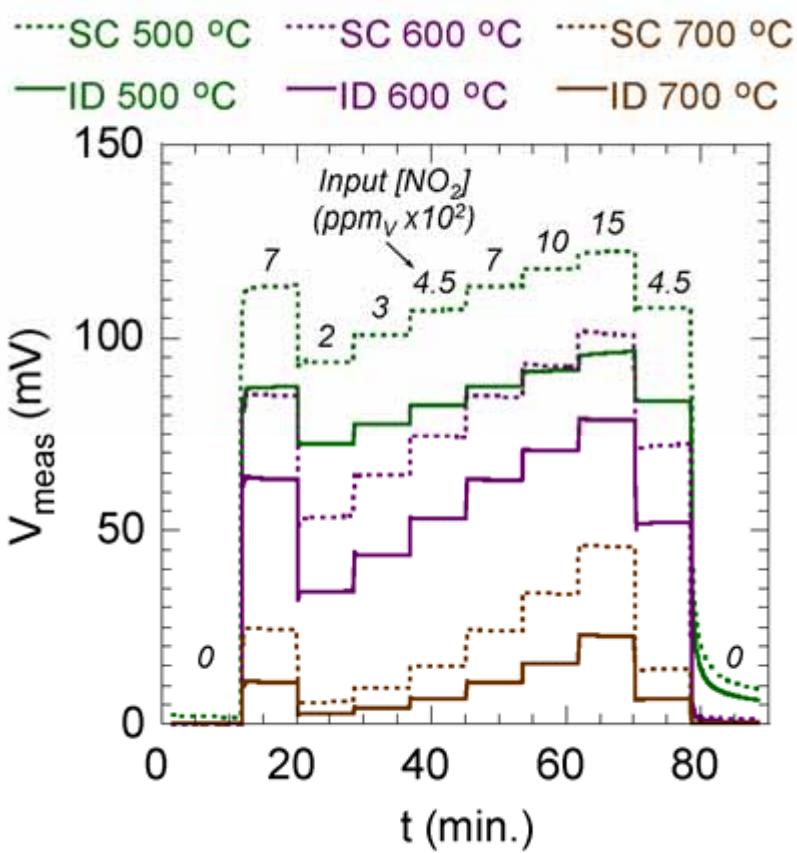
Varying [O₂] with 0 ppm_v NO₂



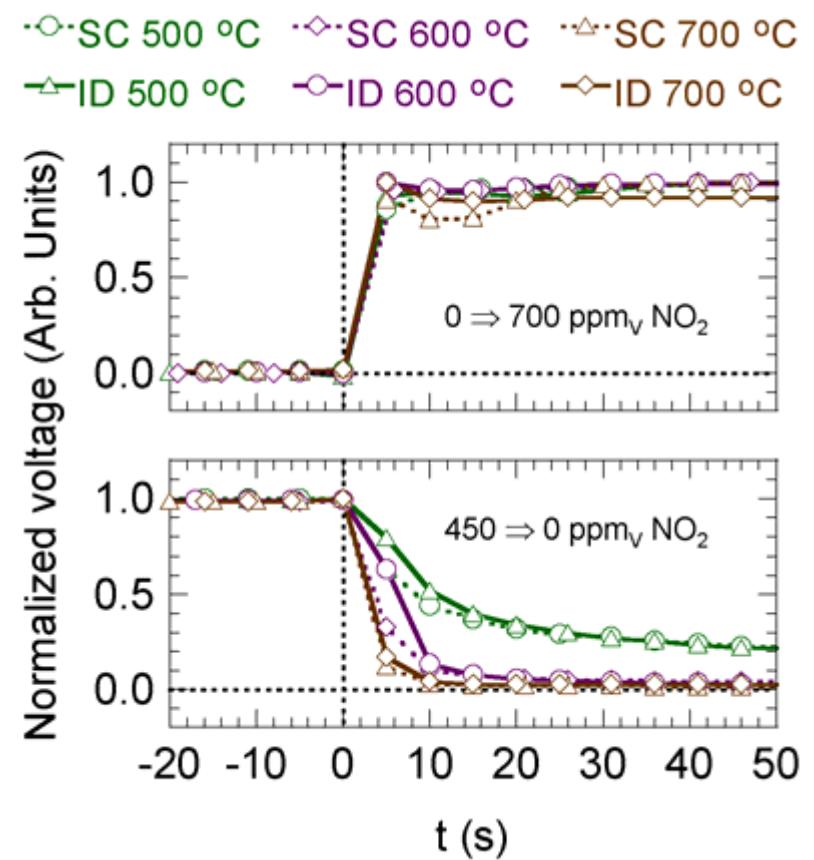
⇒ LSC/Pt sensing element, semicircular (SC) geometry.

T controls signal magnitude, recovery time

Varying $[NO_2]$



Step response / recovery

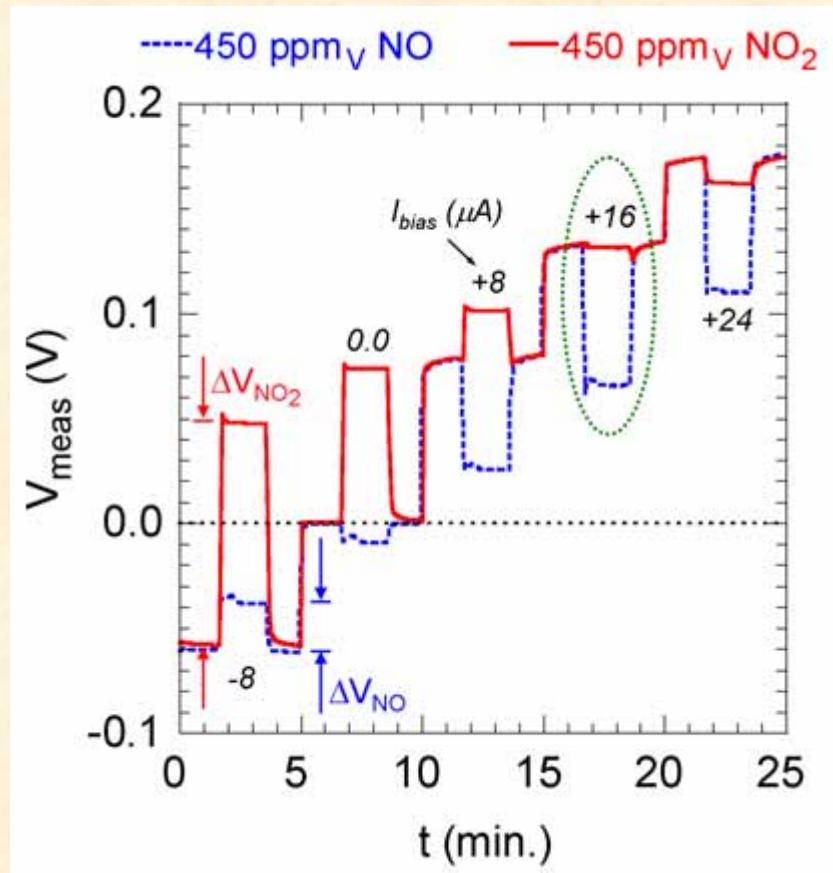


⇒ SC = "semicircular", ID = "interdigitated".

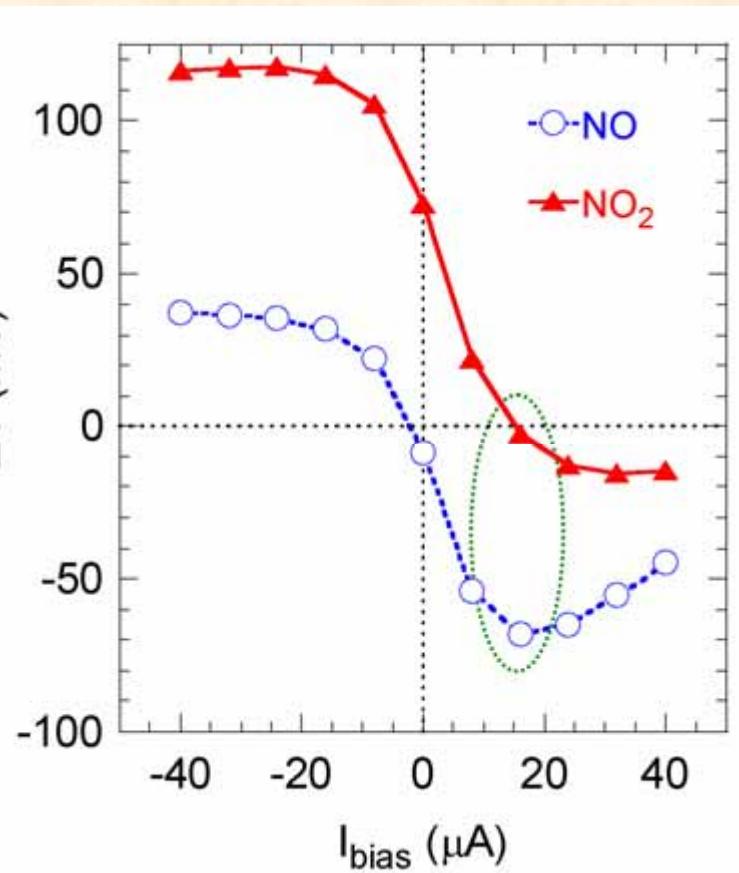
⇒ LSC / Pt sense elements, data collected in 7 vol% O_2 .

Effect of varying I_{bias} on NO_x responses

Pulses of 450 ppm_V NO_x at varying I_{bias}



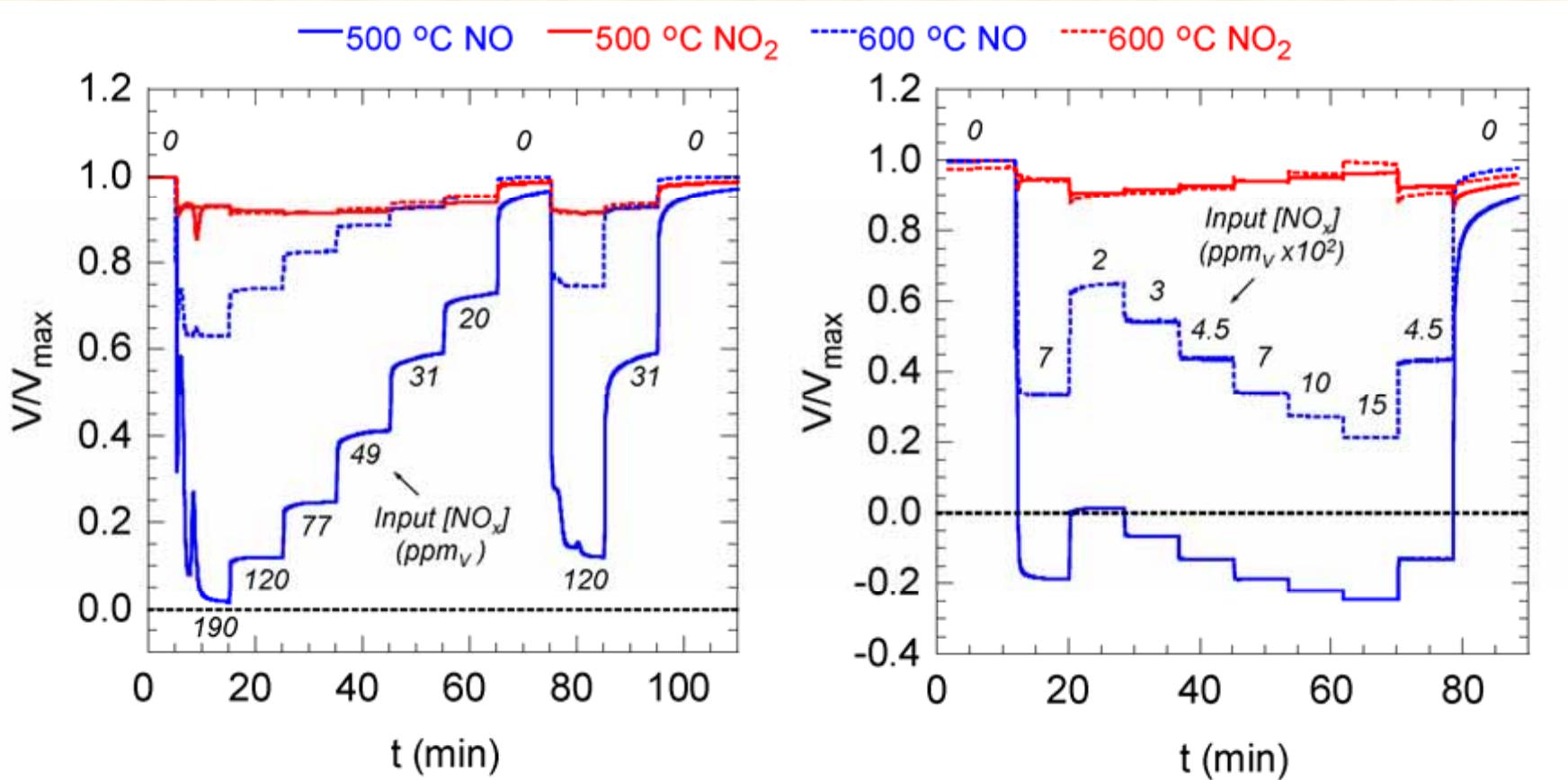
$$\Delta V = f([I_{\text{bias}}])$$



- ⇒ Data collected at 600 °C, 7 vol% O₂. LSC/Pt, semicircular (SC) geometry.
- ⇒ "Positive bias": Oxide electrode +, Pt electrode -.

Asymmetry in biased response over wide $[NO_x]$

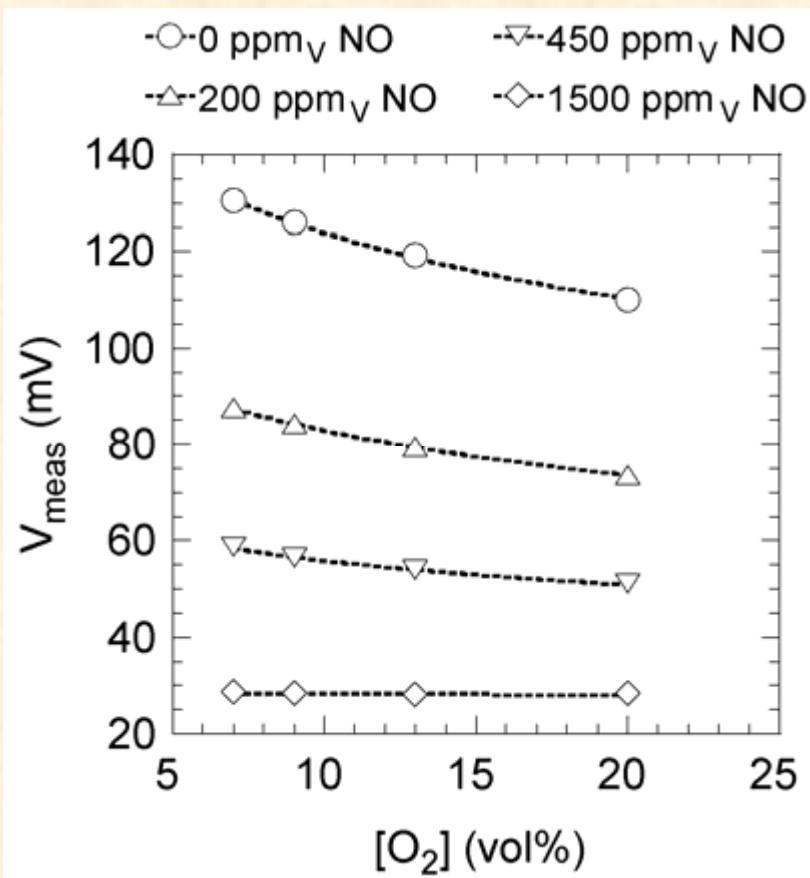
$V_{\text{meas}} = f(t)$ (LSC/Pt SC sensing element, 7 vol% O_2)



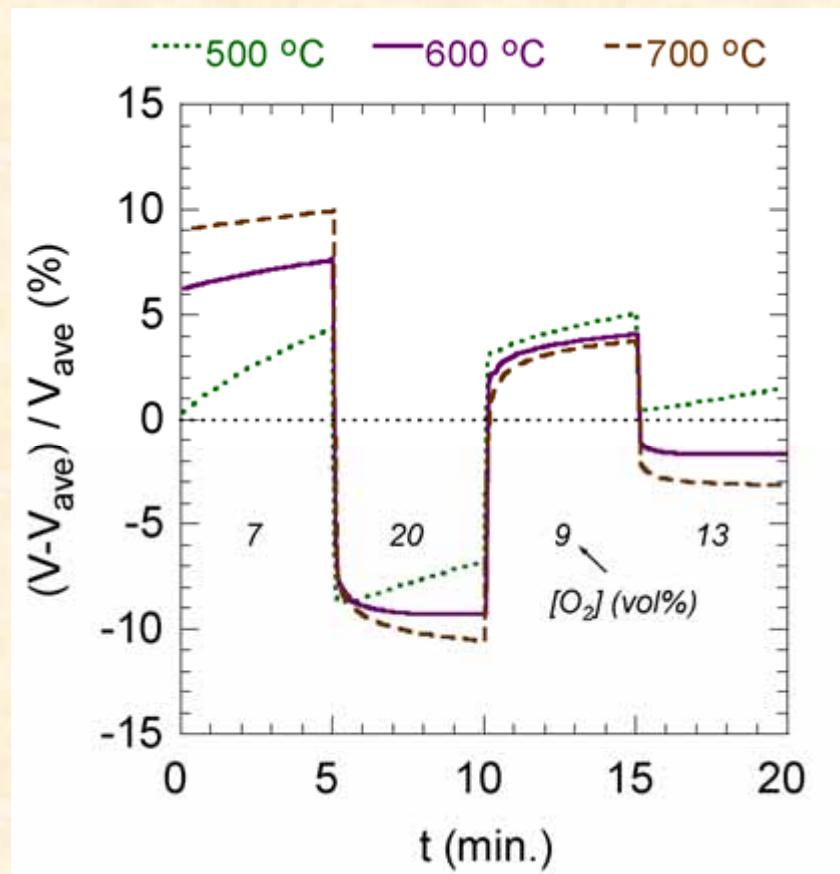
- ⇒ +1.5 (500 °C) and +14 (600 °C) μA biases.
- ⇒ Focus on NO response with biased elements.

Biased: $[O_2]$ dependence a decreasing function of $[NO]$

Varying $[O_2]$ at 600 °C



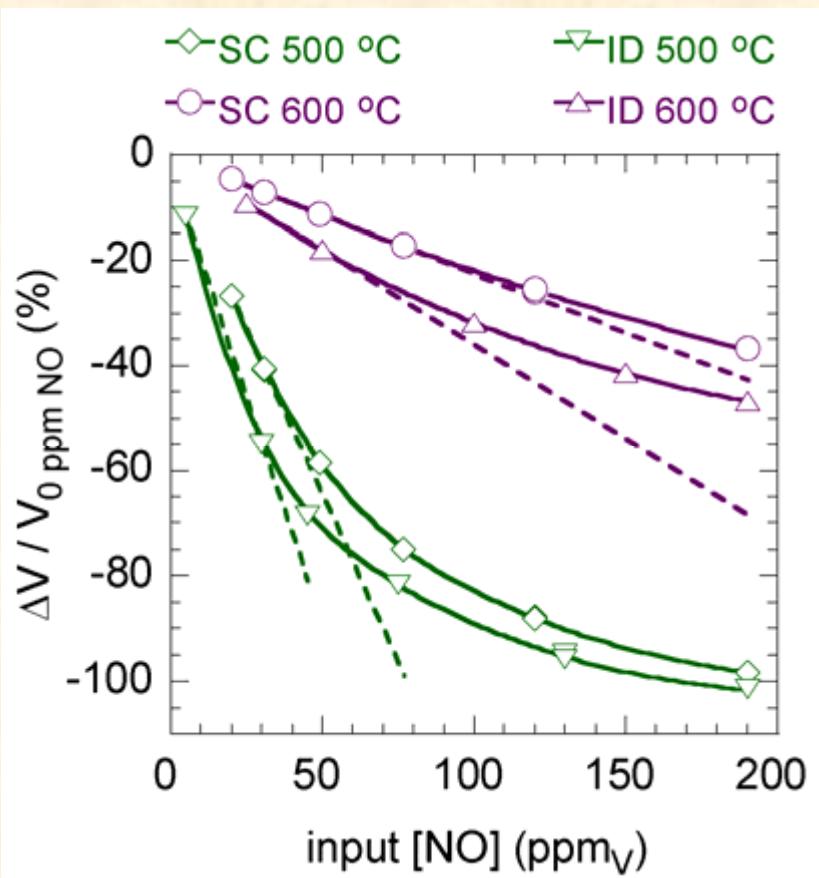
$V = f(t)$ with 0 [NO]



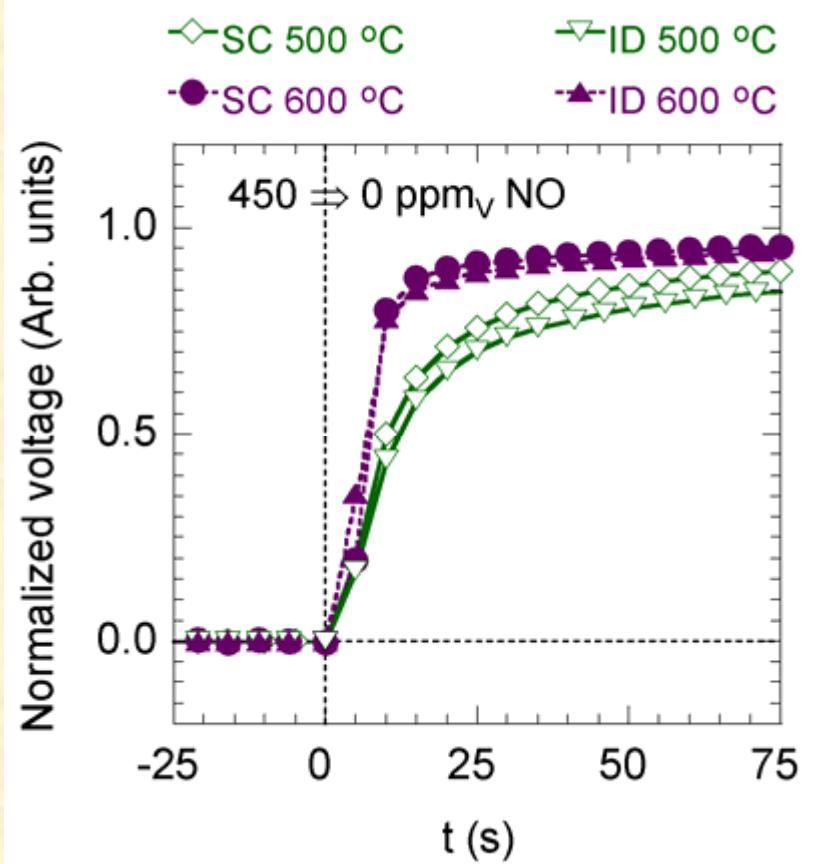
⇒ LSC /Pt semicircular (SC) sensing element. 700 °C bias = 60 μ A.

T still controls response magnitude, recovery time

$$\Delta V = f([NO])$$



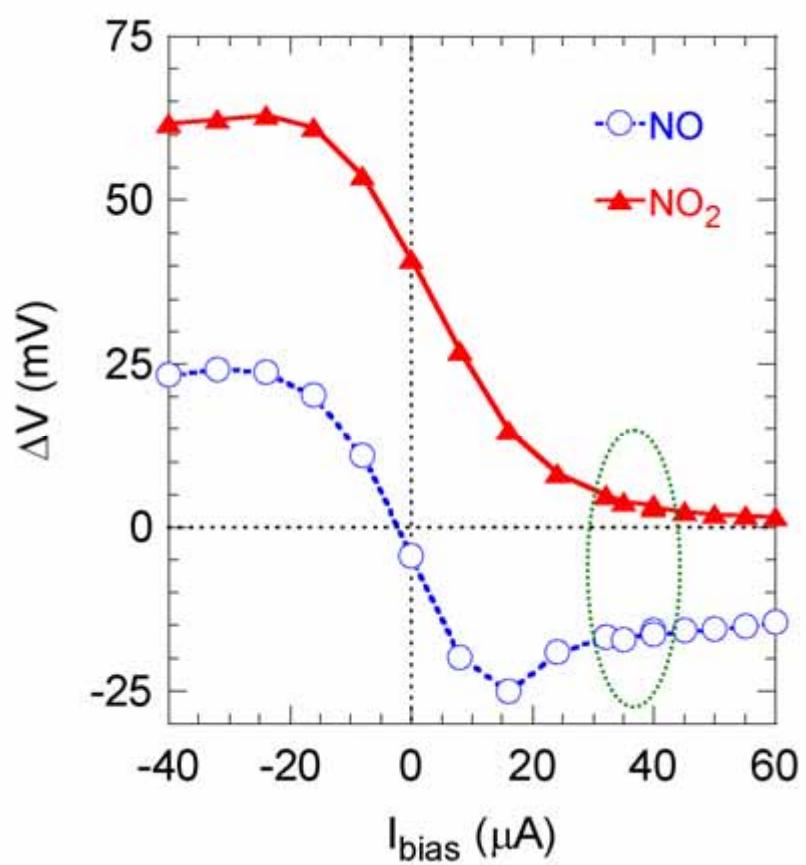
Recovery from 450 ppm_V NO



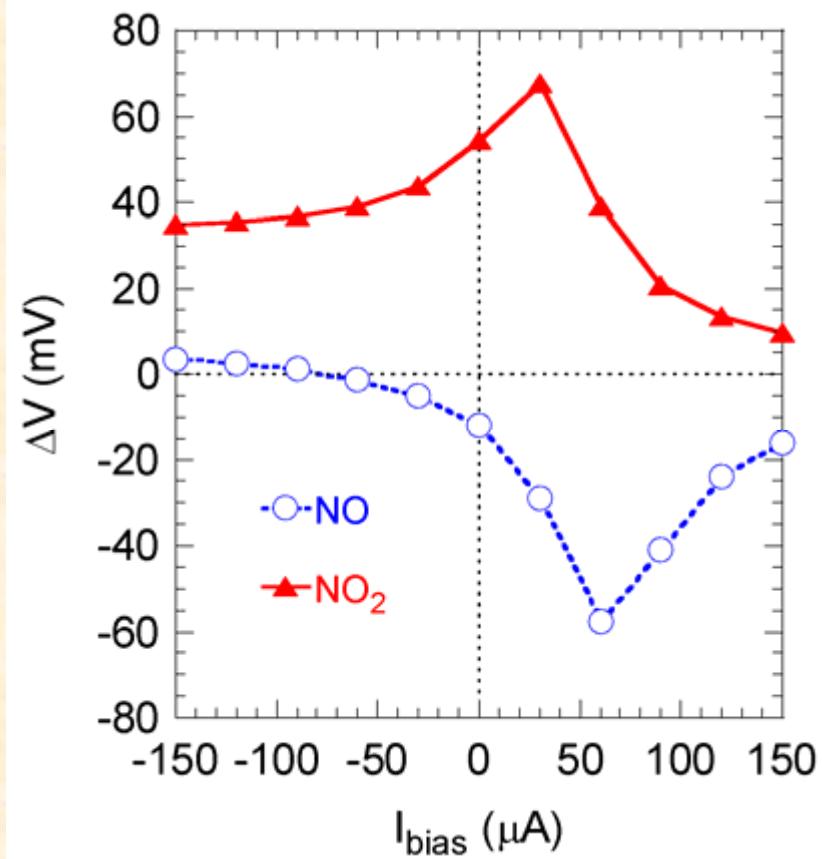
- ⇒ LSC /Pt sensing elements.
- ⇒ Biased to "NO-selective" condition.

Ferrite behaved differently than chromites with bias

$\text{La}_{0.85}\text{Ba}_{0.15}\text{CrO}_3$ (LBC)



$\text{La}_{0.8}\text{Sr}_{0.2}\text{FeO}_3$ (LSF)



- ⇒ Data collected at 600 °C in 7 vol% O_2 .
- ⇒ LSC /Pt semicircular (SC) sensing elements.

Summary and conclusions

⇒ Experimental approach

- ◆ Sensing elements with co-planar electrodes (oxide /Pt).

⇒ Observations

- ◆ Strong NO₂ response without bias.

⇒ Response logarithmic 20 – 1500 ppm [NO₂].

⇒ Function of [O₂] only in presence of [NO₂].

⇒ Magnitude, recovery time decrease with T.

- ◆ Enhanced NO response possible with DC biasing.

⇒ Response linear at low [NO].

⇒ [O₂] sensitivity inversely proportional to [NO].

⇒ Magnitude, recovery time decrease with T.

⇒ Not all oxides behave similarly.

⇒ Conclusion and future outlook

- ◆ Use of biasing enables sensing of NO as opposed to NO₂.
- ◆ Characterization of stability and selectivity still required.

Acknowledgements

- ⇒ B. L. Armstrong and C. A. Walls (ORNL).
 - ◆ YSZ substrate fabrication.
 - ◆ Screen printing ink formulation and production.
- ⇒ L. C. Maxey and B. E. Evans (ORNL).
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Thank you for your attention!